

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: **TSAI, John C.**

For (title): **SYSTEM FOR ROTATION MEASUREMENT WITH LASER
INTERFEROMETRY**

Filing Date: **20/08/2004**

Serial No: **10/711,090**

Examiner: **LYONS, MICHAEL A.**

Art Unit: **2877**

Mail Stop Non-Fee Amendment
Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313

RESPONSE TO OFFICE ACTION AND AMENDMENT

Sir:

In response to the Office Action dated 11/06/2006, Applicant submits the following remarks and amendment, currently due on a statutory period for response now extending through 02/06/2007.